



<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (use as many sheets as necessary)		<b>Complete if Known</b>	
		Application Number	10/713,219
		Filing Date	November 17, 2003
		First Named Inventor	Shinji MAEKAWA et al.
		Art Unit	2813
		Examiner Name	Laura M. Schillinger
Sheet	1	of	5
		Attorney Docket Number	740756-2670

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code <sup>2</sup> (if known)			
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Examiner Signature	[Signature]	Date Considered	1/5/05
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		Attorney Docket Number	740756-2670

U.S. PATENT DOCUMENTS					
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				Art Unit	2813
				Examiner Name	Laura M. Schillinger
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Examiner Signature	Laura Schillinger			Date Considered	1/5/06

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		Country Code <sup>4</sup> Number <sup>4</sup> Kind Code <sup>2</sup> (if known)				
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JL		Kevin S. Jones, et al., "Boron Diffusion Upon Annealing of Laser Thermal Processed Silicon", ION Implantation Technology 2000 (IEEE 2000), pp. 111-114.	
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